



IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Hodges et al.

Confirmation No.: 8400

Application No.: 10/052,313

Examiner: Lee, H.

Filing Date: 01/18/02

Group Art Unit: 2823

Title: Semiconductor Device with Deposited Oxide

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Sir:

In an Office Action mailed on 07-15-2004, on the above-identified U.S. Patent application, a shortened statutory period of 3 months was set for response. In accordance with 37 C.F.R. 1.136(a), applicant(s) hereby request(s) a:

one month
 two months
 three months
 four months

time extension so that the period for response to the Office Action expires on 11-15-2004. Authorization to charge the fee required by 37 CFR 1.17 to Deposit Account 08-2025 appears in the enclosed transmittal letter. At any time during the pendency of this application, please charge any fees required or credit any over payment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16 through 1.21 inclusive, and any other sections in Title 37 of the Code of Federal Regulations that may regulate fees. A duplicate copy of this sheet is enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as:

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in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.

Date of Deposit: 11-15-2004

Typed Name: Carlin Taylor

Signature: Carlin Taylor

Respectfully submitted,

Hodges et al.

By 

William J. Breen, III

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Date: 11/15/04

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